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Bib Data Sheet

CONFIRMATION NO. 7953

SERIAL NUMBER 10/625,452	FILING DATE 07/23/2003  RULE	CLASS 438	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. 5649-1144
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\*\* CONTINUING DATA \*\*\*\*\* NGR LV

\*\* FOREIGN APPLICATIONS \*\*\*\*\* YFL LV

REPUBLIC OF KOREA 10-2002-0066087 10/29/2002 NO

REPUBLIC OF KOREA 10-2002-0050120 08/23/2002 NO

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 03/16/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature _____ Initials <u>LV</u>	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 11	TOTAL CLAIMS 21	INDEPENDENT CLAIMS 2
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## TITLE

Methods of forming semiconductor devices using an etch stop layer

FILING FEE

FEES: Authority has been given in Paper

<input type="checkbox"/> All Fees
<input type="checkbox"/> 1.16 Fees ( Filing )
<input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )